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Docket No. 8733.857.00
(PATENT)

Entered by
RCF
08/08/06

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hong Chul KIM

Customer No. 30827

Application No. 10/608,100

Confirmation No. 8090

Filed: June 30, 2003

Art Unit: 2629

For: **ALIGNING METHOD UNDER ELECTRIC
FIELD FOR FERROELECTRIC LIQUID
CRYSTAL AND LCD USING THE SAME**

Examiner: Stephen G. Sherman

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE AFTER FINAL
UNDER 37 C.F.R. § 1.116

Sir:

In response to the final Office Action dated May 4, 2006, please amend the patent application identified above as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.